

11017 U.S. PTO
10/033100
10/25/01

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10033100	FILING DATE 10/25/2001	CLASS 438	SUBCLASS 6749	GAU 2812	EXAMINER B...
**APPLICANTS: Yamazaki Shunpei; Konuma Toshimitsu; Nishi Takeshi; <div style="text-align: right;">2818</div>					
**CONTINUING DATA VERIFIED:					
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** FOREIGN APPLICATIONS VERIFIED: JAPAN 2000-326278 10/26/2000					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO 07977-287001 / US5276	
TITLE : Film formation apparatus and film formation method					

U.S. DEPT. OF COMM. / PAT & TM / PTO-356L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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